



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q58688

Masaharu OGAWA

Allowed: October 16, 2003

Appln. No.: 09/620,707

Group Art Unit: 2882

Confirmation No.: 3363

Examiner: Chih-Cheng G. KAO

Filed: July 20, 2000

For: SOLID STATE RADIATION DETECTOR

STATEMENT OF SUBSTANCE OF INTERVIEW

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please review and enter the following remarks summarizing the interview conducted on September 25, 2003:

REMARKS

Although an Interview Summary Record (PTO-413) was not attached with the Notice of Allowance dated October 16, 2003, the Notice of Allowance (page 2) indicates that the claims were amended by Examiner's amendment as authorized during a telephone interview initiated by the Examiner with the undersigned on September 25, 2003. The Examiner's amendment includes a complete and proper recordation of the interview and authorized claim amendments. Therefore, no further recordation by the Applicant is believed to be required. Nevertheless, Applicant states the following.

In the telephonic interview conducted on September 25, 2003, it was agreed to amend claims 3 and 4, lines 3 and 4, to delete the phrase "Idemitsu indium X-metal oxide (IDIXO, produced by Idemitsu Kosan)," as shown in the Examiner's Amendment attached to the Notice

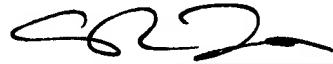
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of Allowance. No exhibits were shown or demonstrations conducted. No prior art was discussed.

It is believed that no petition or fee is required. However, if the USPTO deems otherwise, Applicant hereby petitions for any extension of time which may be required to maintain the pendency of this case, and any required fee, except for the Issue Fee, for such extension is to be charged to Deposit Account No. 19-4880.

Respectfully submitted,



Christopher R. Lipp
Registration No. 41,157

SUGHRUE MION, PLLC

Telephone: (202) 293-7060

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WASHINGTON OFFICE

23373

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SUBMISSION OF DRAWINGS

MAIL STOP ISSUE FEE

ATTN: OFFICIAL DRAFTSPERSON

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Submitted herewith please find six (6) sheets of drawings in compliance with 37 C.F.R. § 1.84. The Examiner is respectfully requested to acknowledge receipt of these drawings.

The submitted drawings incorporate the proposed drawing changes approved in the Notice of Allowance dated October 16, 2003.

Respectfully submitted,

Christopher R. Lipp
Registration No. 41,157

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